

L Number	Hits	Search Text	DB	Time stamp
1	25	photolithography same (solar or photovoltaic) same (GaAs or (iii adj v))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/03/18 06:41
4	81	(photolithograph\$2 same (GaAs or (iii adj v))) and (solar or photovoltaic)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/03/18 06:48
5	71	photolithograph\$2 and 136/244.ccls.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/03/18 06:48
6	25	(photolithograph\$2 and 136/244.ccls.) and (gaas or (iii adj v))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/03/18 06:49
7	27	((photolithograph\$2 same (GaAs or (iii adj v))) and (solar or photovoltaic)) and mm	USPAT	2003/03/18 06:55
8	226	photolithography and (square near1 millimeter)	USPAT	2003/03/18 06:57
9	3	(photolithography and (square near1 millimeter)) and (solar or photovoltaic)	USPAT	2003/03/18 06:56
10	229	photolithography and (square\$1 near1 millimeter)	USPAT	2003/03/18 06:57
11	9	(photolithography and (square\$1 near1 millimeter)) and (solar or photovoltaic or photoelectric)	USPAT	2003/03/18 06:57

L Number	Hits	Search Text	DB	Time stamp
2	117	136/\$.cccls. and sawing	USPAT	2003/03/18 07:45
3	13	(136/\$.cccls. and sawing) and gaas	USPAT	2003/03/18 07:47
4	4	((136/\$.cccls. and sawing) and gaas) and photolithography	USPAT	2003/03/18 07:47